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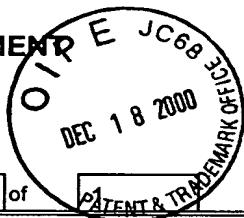
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273954

SPO-2424

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**



Date: December 18, 2000

Page 1 of 1

Applicant: ISHIWATA et al.

Appln. No.: 09/664,723

Filing Date: September 19, 2000

Examiner: Unknown

Group Art Unit: 2872

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
SAT	AR 5,751,475	05/1998	ISHIWATA et al.			
SAT	BR 5,969,855	10/1999	ISHIWATA et al.			
	CR					
	DR					
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					
	MR					
	NR					

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
SAT	OR	9-15504	01/1997	Japan	ISHIWATA	X			X
	PR	7-239212	09/1995	Japan	NODA	X			X
	QR	7-248261	09/1995	Japan	SASAKI et al.	X			X
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	TR								
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	VR								
	WR								
	XR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

SAT	YR	DUBOIS et al, "Real-Time Reflectivity and Topography Imagery of Depth-Resolved Microscopic Surfaces", OPTICS LETTERS, Vol. 24, No. 5, March 1999, pp.309-311				
	ZR					
	AAR					
	BBR					

Examiner SAT. TURNER

Date Considered: 3-6-03

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.